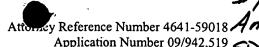
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Application Number 09/942,519

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of: Okino

Application No. 09/942,51

Filed: August 29, 2001

CHARGED-PARTICLE-BEAM For:

> MICROLITHOGRAPHY METHODS AND APPARATUS PROVIDING REDUCED

RETICLE HEATING

Examiner: Lam S. Nguyen

Date: July 16, 2003

Art Unit: 2853

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on July 16, 2003, as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 2313-1450.

torney for Applicant

COMMISSIONER FOR PATENTS P.O. BOX 1450 **ALEXANDRIA, VA 22313-1450**

AMENDMENT AND REPLY TO OFFICE ACTION

This responds to the Office action dated January 16, 2003. Please amend the referenced application as follows:

Amendments to the Specification begin on page 2.

Remarks begin on page 4.